

Notice of References Cited	Application/Control No. 10/559,907		Applicant(s)/Patent Under Reexamination GUO ET AL.	
	Examiner CHRISTINE CHEN		Art Unit 4116	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,902,579	02-1990	Grasselli et al.	428/610
*	B	US-5,429,725	07-1995	Thorpe et al.	205/631
*	C	US-4,595,429	06-1986	Le Caer et al.	148/403
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP0361136	04-1990	Europe	Kogyo et al.	
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NON-PATENT DOCUMENTS

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	U	Seiki et al., Resistance Thermometer Element, 4/6/1984, JP59060233 abstract, translation via EPO esp@cenet
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.